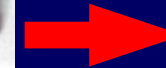
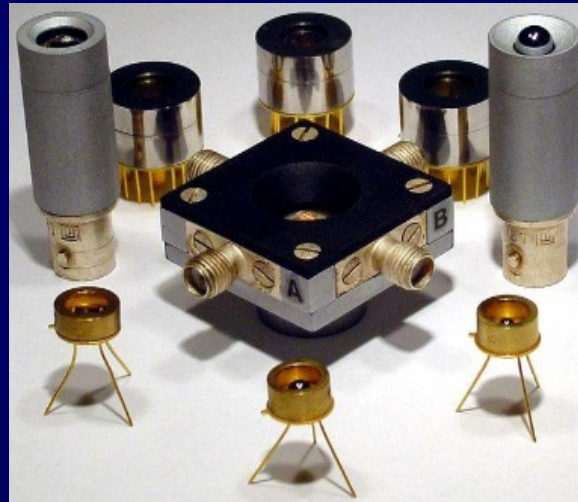
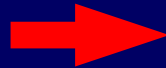




Fast and sensitive photodetection of long wavelength IR radiation without cryocooling

2-16 μm , 190-300 K



Jozef Piotrowski
VIGO System S.A.
129/133 Poznanska St
05-850 OZARÓW MAZ., PL

www.vigo.com.pl
jpiotr@vigo.com.pl
jpiotr@skype.com

INFN SEMINAR
FRASCATI 21.09.2010



VIGO SYSTEM S.A.



-a SME for research, development and commercialization of optoelectronics

- ▶ **Team: ~60 workers: 9 PhD, 15 engineers**
- ▶ **Dpts: Detector, MOCVD Lab, Electronics, Optical Coating, Sales**
- ▶ **2 facilities**



labs and offices



production facility

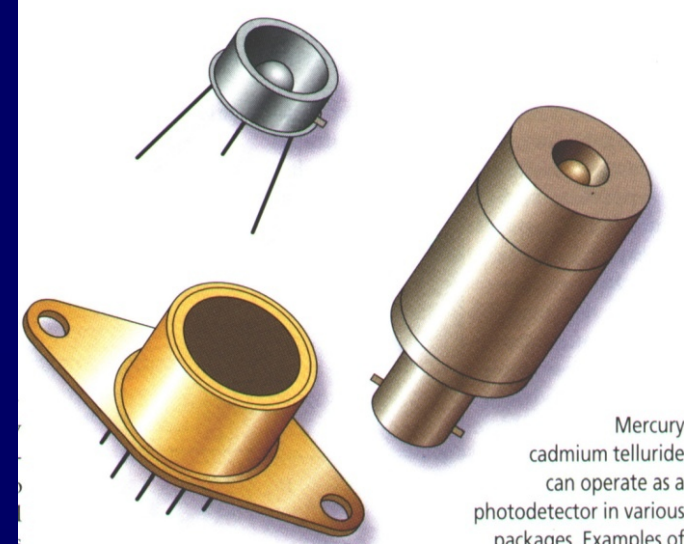
labs under construction

VIGO SYSTEM MISSION:

Perfect, fast and convenient IR sensing at
MWIR and LWIR

THE GOAL: „HOT” photodetectors

- ▶ fundamental limits of D^*
- ▶ wide bandwidth (GHz)
- ▶ any wavelength (2-16 μm)

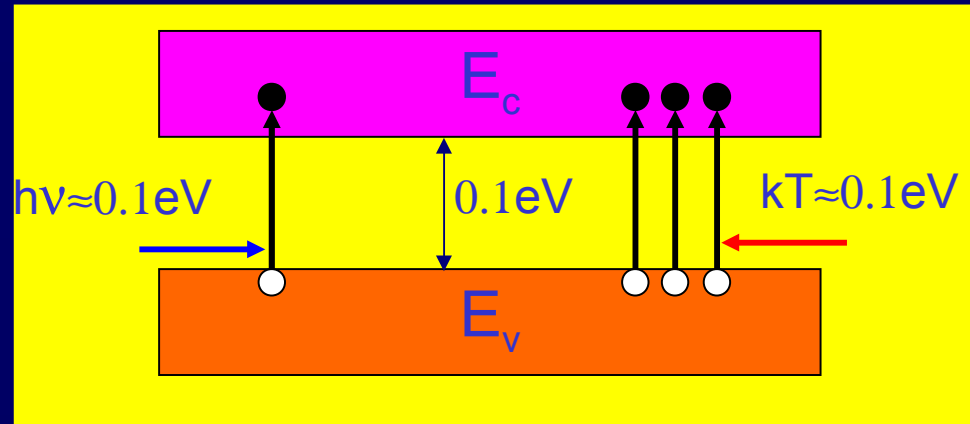


**KNOWLEDGE-BASED HIGH TECH PRODUCTS
for GLOBAL MARKET**

- ▶ Versatile manufacturing- small /volume
- ▶ Short time-to-market
- ▶ Niche strategy- unique products

Why IR detectors cooled? *-thermal generation*

$T=300\text{ K}$
 $\lambda=10\ \mu\text{m}$



- ▶ $h\nu \approx kT$
- ▶ huge ($\approx 10^{25}\text{ cm}^{-3}\text{s}^{-1}$) thermal G-R (Auger, radiative, SHR)!
- ▶ noise due to statistical nature of G-R
- ▶ D^* limited by G-R noise
- ▶ cooling

„The need for cooling is a major limitation of infrared photodetectors that prevents more widespread use of infrared technology“

C. T. Elliott

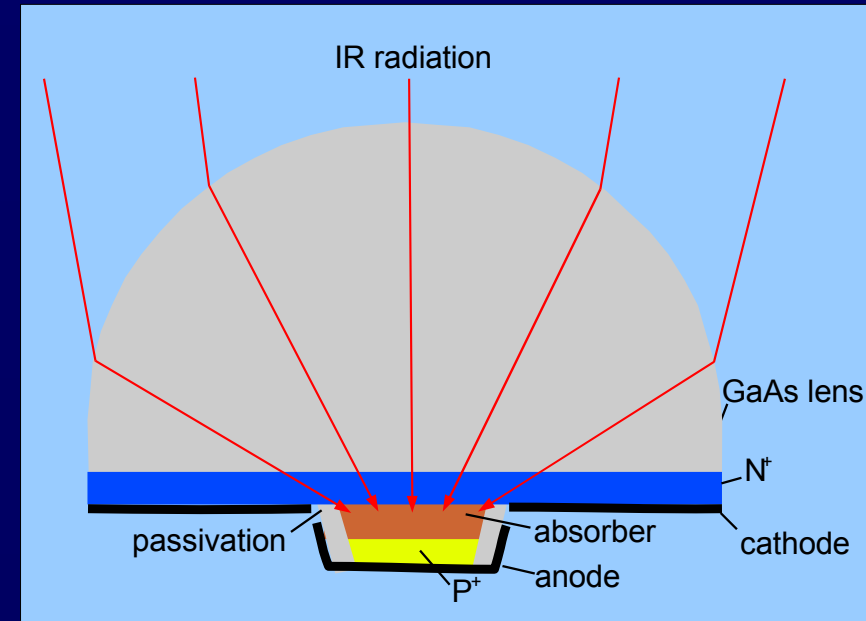
But thermal generation can be prevented!

Vigo Concept of IR Photodetector

*-integration of optical, detection and electric functions
in one chip*

Functions:

- ▶ concentration of radiation
- ▶ enhanced absorption
- ▶ efficient/fast collection of charge carriers
- ▶ suppression of thermal generation with design of active element
- ▶ shielding against unwanted radiation
- ▶ minimized parasitic impedances
- ▶ gain
- ▶ and other...



Optimization: $\max I_{ph}/I_n$
for a given λ and f

The concept used in uncooled PC, PV, Dember and magnetoconcentration devices

- ▶ high performance
- ▶ fast response
- ▶ convenient operation

HOT Detectors at VIGO Systems

- ▶ Pre-Vigo era:
 - importance of HOT recognized in early 60-ties
 - uncooled 10.6um PC and PEM demonstrated in 1970
- ▶ Vigo Systems S.A. since 1984
 - 1984- open tube ISOVPE- a success story
 - 1985- commercial PC, PEM and PV devices
 - monolithic immersion 3D architecture concept of IR devices
 - multiple heterojunction devices
- ▶ MOCVD era:
 - advanced heterostructures
 - GaAs μ -optics
 - improved sensitivity and response speed
 - shaped spectral response & multicolor devices
 - 2008- Vigo facilities in Ozarow

HgCdTe- THE MATERIAL of CHOICE for MWIR/LWIR PHOTODETECTORS

Advantages:

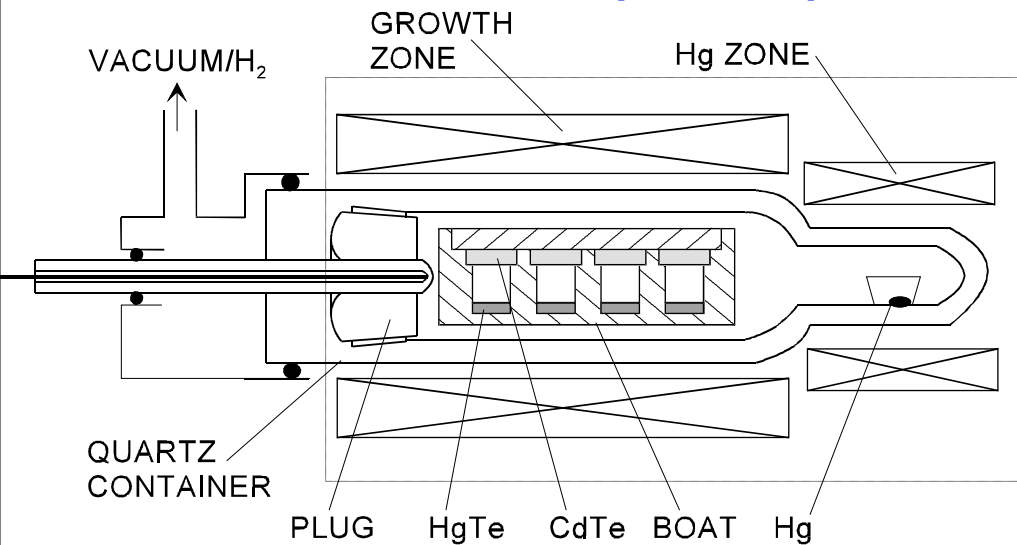
- ▶ band gap tunability 0-1.4 eV → X, UV, V, SWIR, MWIR, LWIR
- ▶ large α/g_{th} → high performance
- ▶ lattice constant vs. x → any complex 3D heterostructures

Problems:

- ▶ **Uniformity issues** → arrays problems
- ▶ **Weak Hg-Te bond** → native defects, stability
- ▶ **Difficult technology** → costly

Two techniques of HgCdTe growth

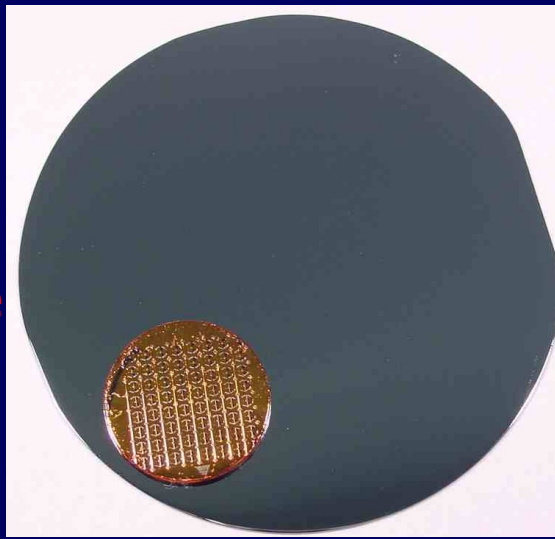
ISOVPE (500°C)



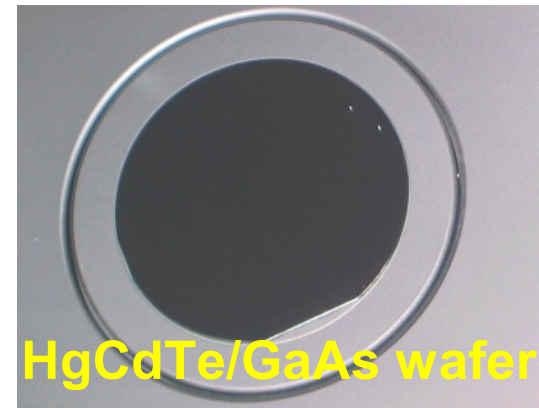
MOCVD (350°C)



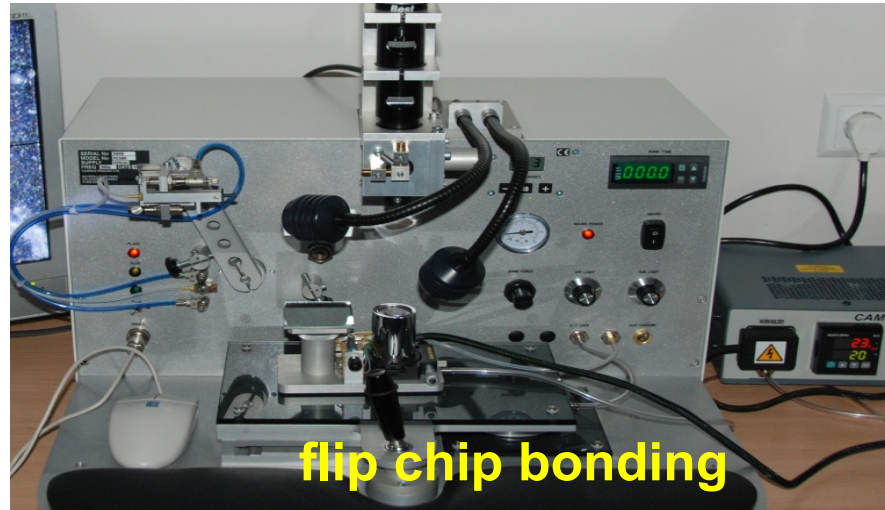
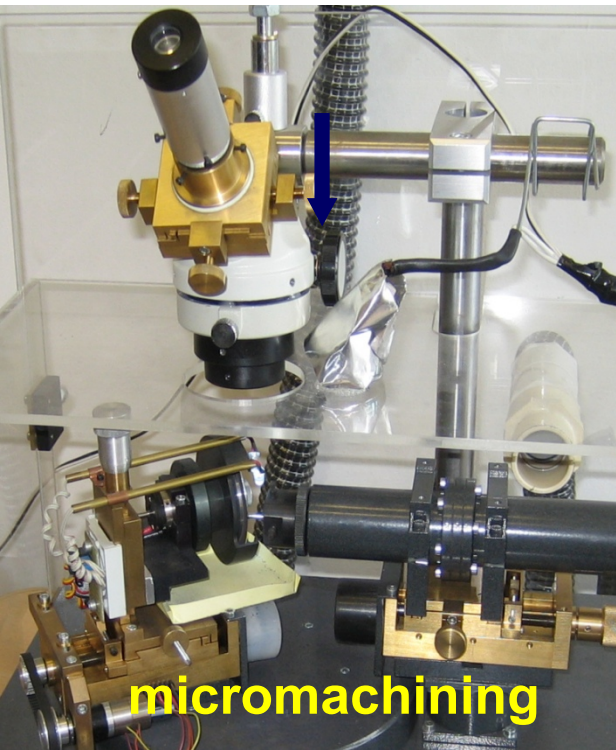
- ▶ versatile technique
- ▶ low consumption of Hg, Cd, Te
- ▶ low cost equipment
- ▶ convenient anneal *in situ*
- ▶ efficient As doping
- ▶ higher growth temperature
- ▶ soft interfaces
- ▶ limited wafer area



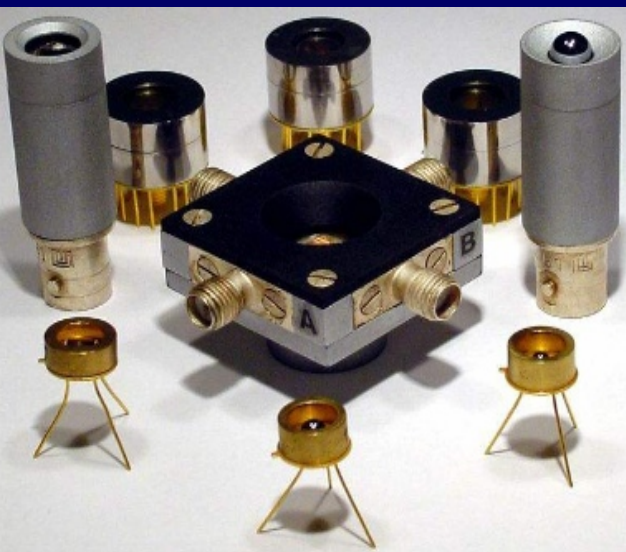
- ▶ MOCVD IMP mode
- ▶ complex band gap/doping profile
- ▶ more sharp interfaces
- ▶ easy I and As dopants activation
- ▶ large wafers
- ▶ more difficult anneal *in situ*
- ▶ costly growth system



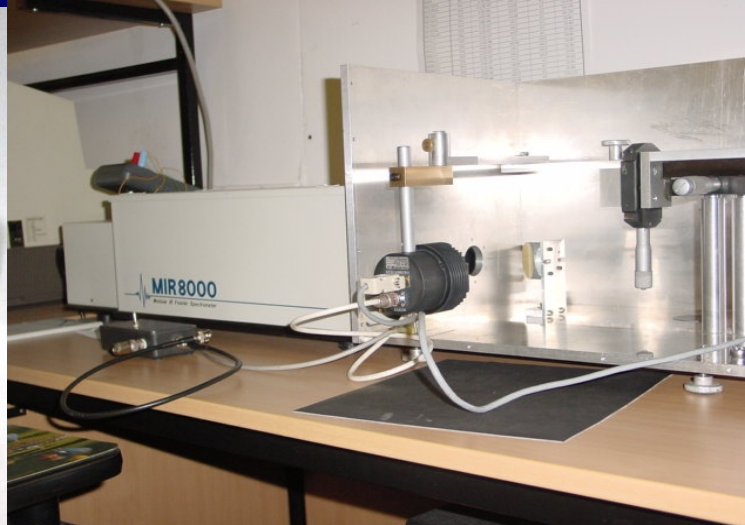
Processing of HgCdTe devices



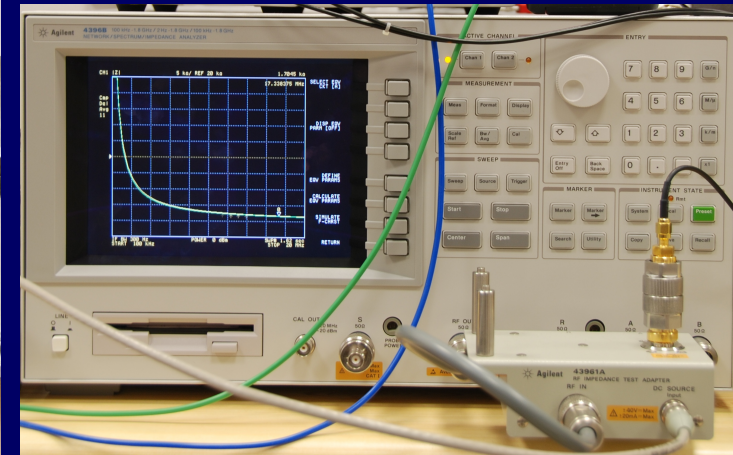
Packaging and Quality Control



detector packages



spectral response with FTIR



I-V, C-V, noise v.s. bias
using signal/impedance
analyzers



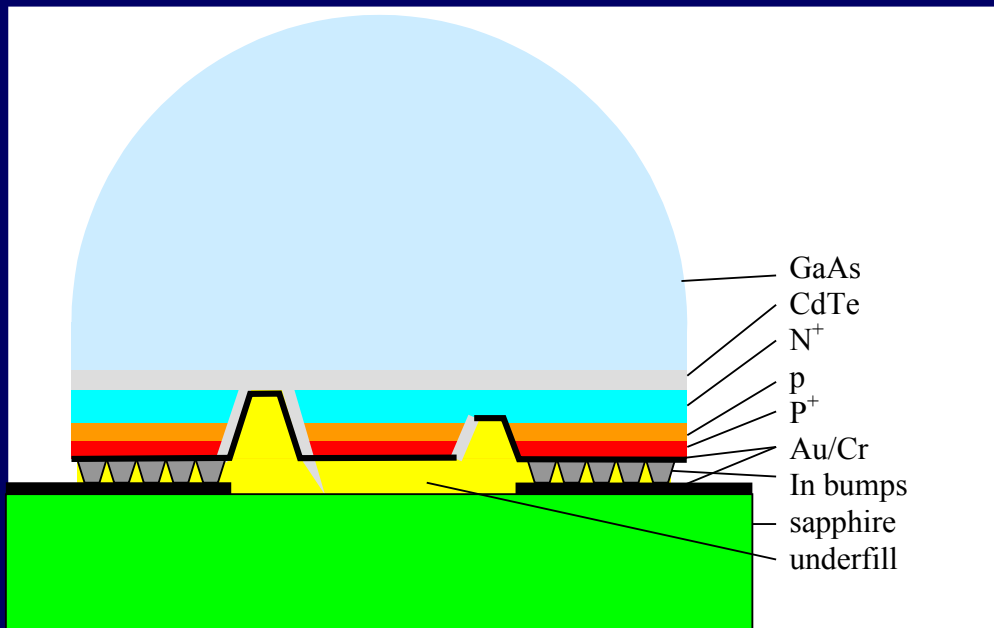
response time with OPO pulses
UV to 16 μm , 25 ps pulses, 2 MW



response time with QC lasers

MONOLITHIC OPTICAL IMMERSION

-Vigo approach to IR concentrator



backside illuminated immersed photodiode

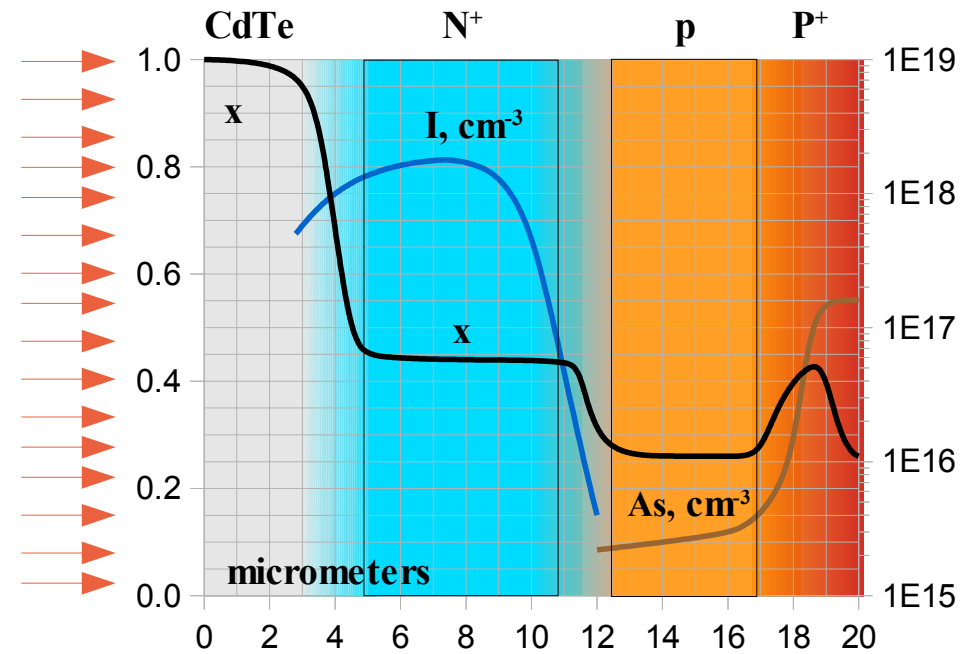
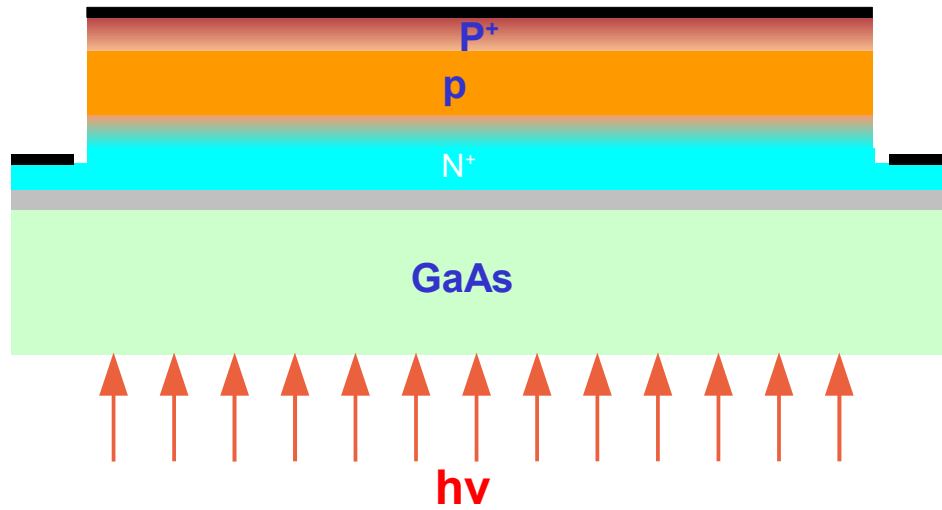
μ -lenses formed in GaAs, CdZnTe or Si

- no glue \rightarrow no reflection/absorption losses
- backside reflection
- 3D heat dissipation
- shield against thermal radiation

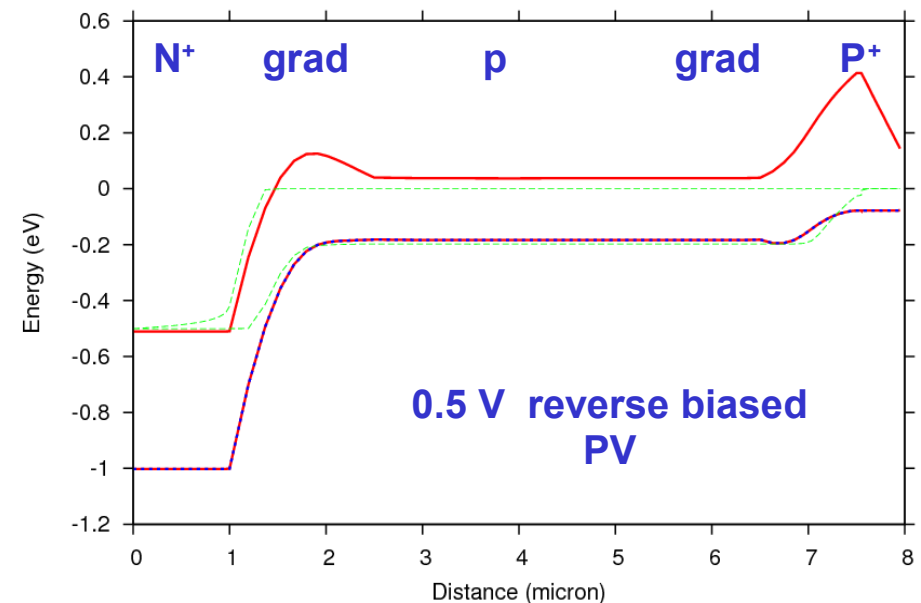
huge gains:

- $n^2=10$ in D^*
- $n^4=100$ in τ_{RC}, P

Band gap engineered graded gap HgCdTe photodiodes

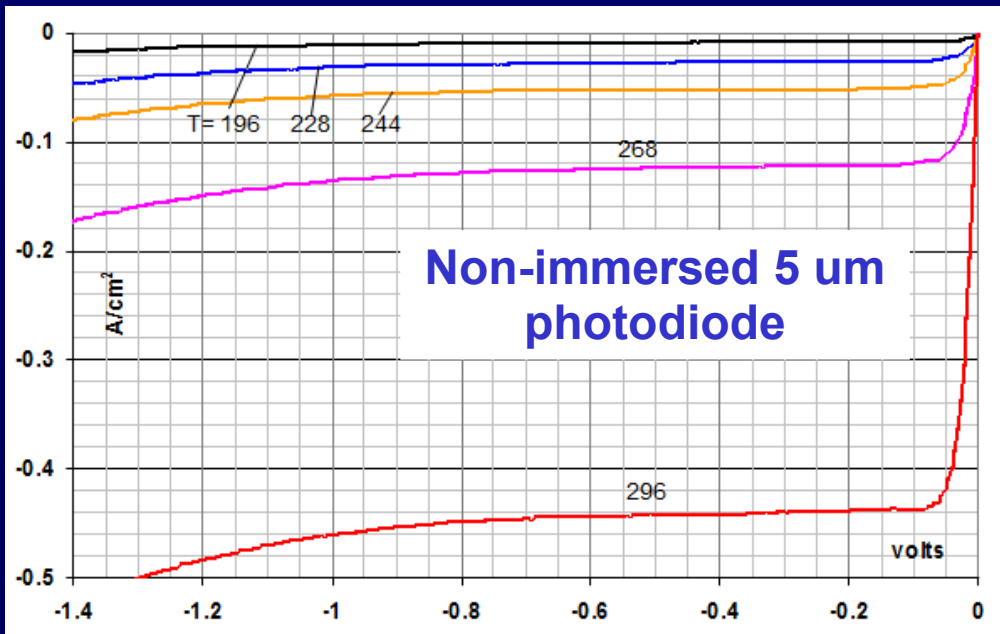


- ▶ Computer designed
 - N⁺: mesa base, electron contact and IR window
 - p: absorber
 - P⁺: hole contact
- ▶ Graded gap interfaces
- ▶ Programed MOCVD growth

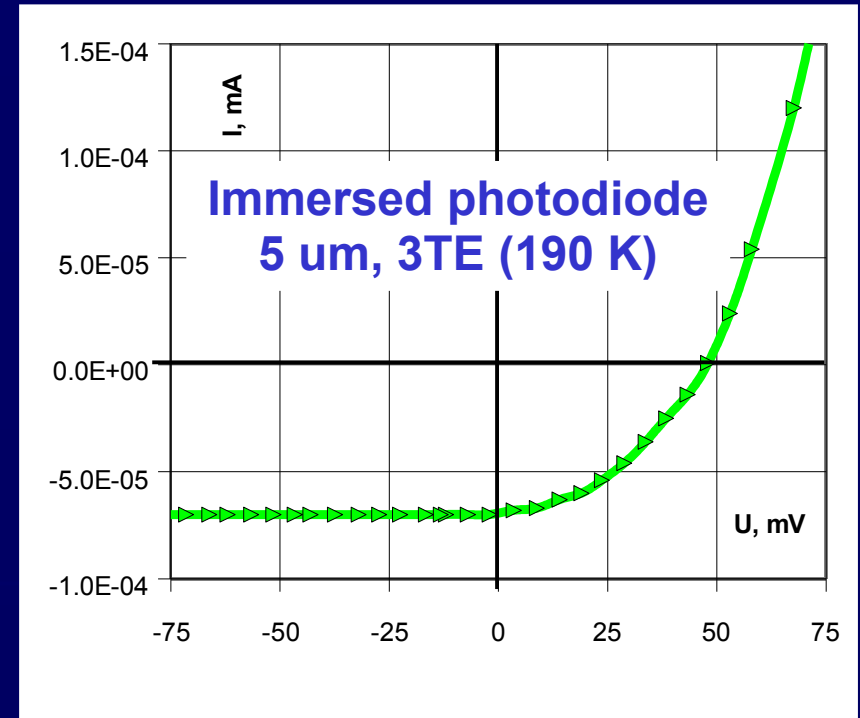


MWIR Photodiodes

-uncooled and Peltier cooled 3-8 um photodiodes



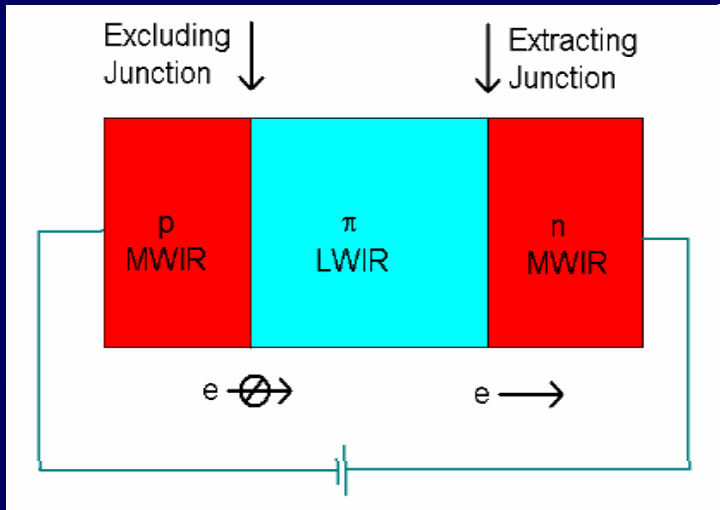
- good saturation of dark current
- J_{sat} generated in absorber
- dark current larger than BLIP current
- but with hyperhemispherical immersion 180° BLIP limit achieved at ~270 K



- current mostly due to background radiation
- $\sim 36^\circ D^*_{BLIP}$ at 230 K

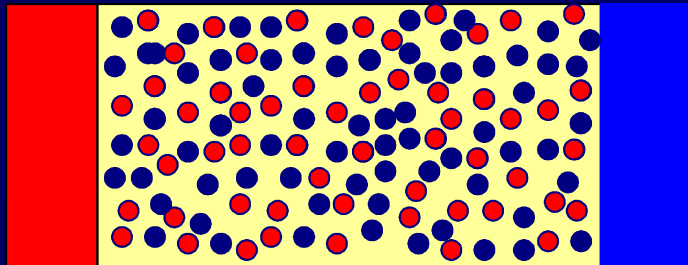
LWIR (8-16um) photodiodes

- *AUGER generation suppression*

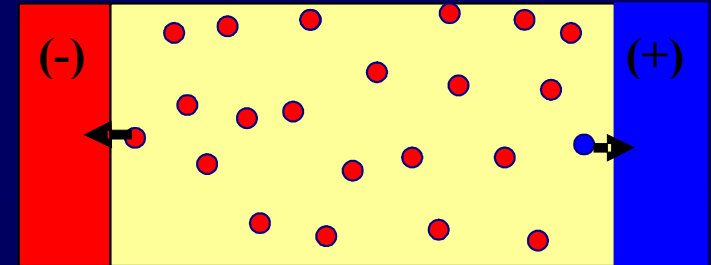


$$N_a \approx 1E15 \text{cm}^{-3}, \quad n_i \approx 6E16 \text{cm}^{-3} \text{ (300 K)}$$

$$G_A = \frac{n}{2\tau_{A1}^1} + \frac{p}{2\tau_{A7}^1} = \frac{1}{2\tau_{A1}^1} \left(n + \frac{p}{\gamma} \right)$$



$$V=0 \quad n \approx p \approx n_i$$



$$V=-0.3V \quad n \approx 0 \quad p = N_a$$

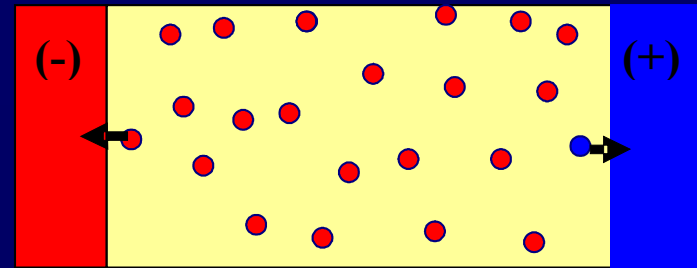
$$G_A = \frac{n_i(\gamma + 1)}{2\tau_{A1}^1\gamma}$$

$$G_A = \frac{N_A}{2\tau_{A1}^1\gamma} \quad D^* = \frac{\lambda}{hc} \frac{\eta}{t^{1/2}} \left(\frac{\tau_{A1}^i}{N_a/\gamma} \right)^{1/2}$$

Dramatic consequences!

Material

- ▶ Deep depletion:
 - no electrons
 - much less holes
- ▶ Large ambipolar mobility (=electron mobility)
- ▶ Reduced thermal generation/recombination



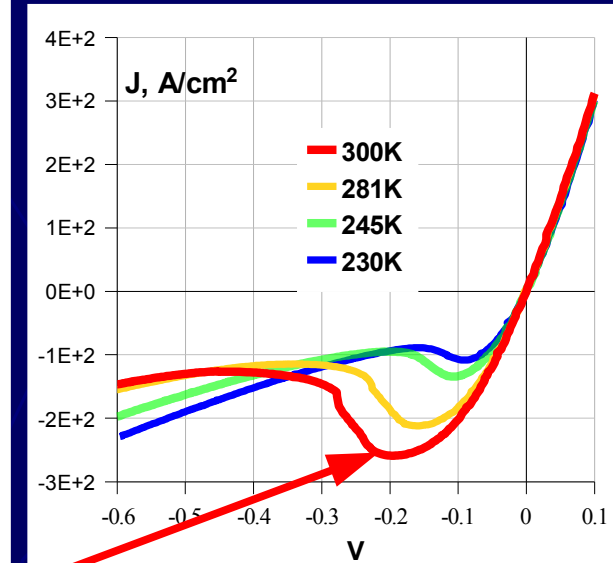
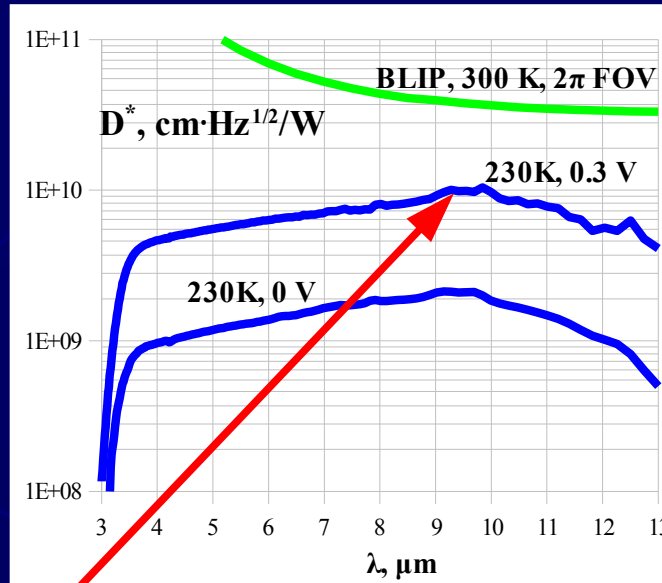
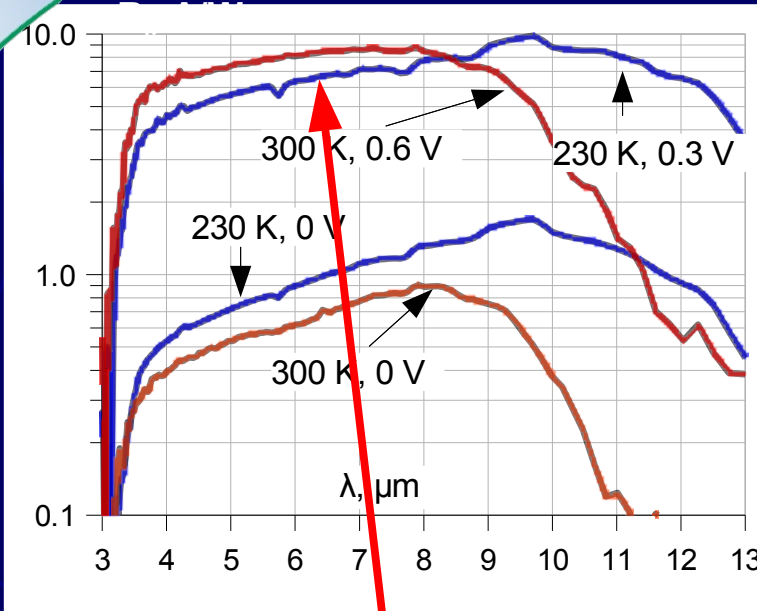
Detectors

- ▶ Reduced dark current and shot noise
- ▶ Large R_d
- ▶ Elimination of Burstein-Moss
- ▶ Improved D^*

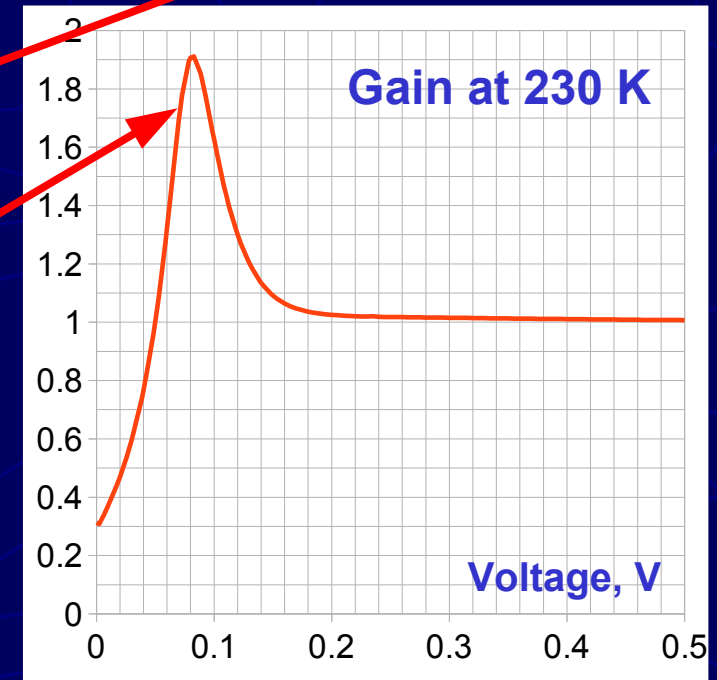
Other devices

- ▶ Low voltage high frequency electronics for computers

Spectral response and I-V plots in LWIR HgCdTe photodiodes



- R_i and D^* improved with bias and cooling
- Respectable performance at $\sim 10 \mu\text{m}$, 2TE
- Auger suppression observed
- Significant photoelectric gain, up to $\sim 10\times$
- -reduced EMI, less critical electronics
- -nature: negative resistance, positive feedback
- Useful spectral range extended to $>16 \mu\text{m}$



RESPONSE TIME

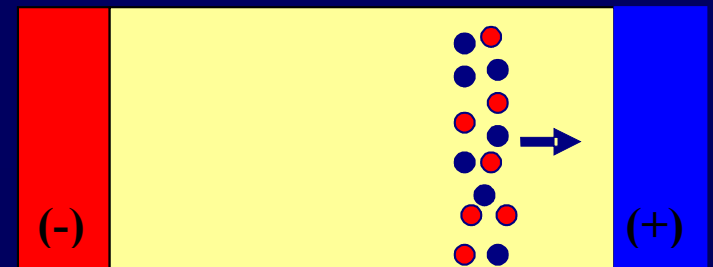
HOT detectors generally fast due to:

- rapid recombination of photogenerated charge carriers
- high mobility
- How to make them more fast?
- increase recombination rate
 - ▶ Very short response time possible by band gap narrowing or/and increase doping
 - ▶ Poor S/N performance due to large generation-recombination
- rapid removal of photogenerated carriers by transport to contacts

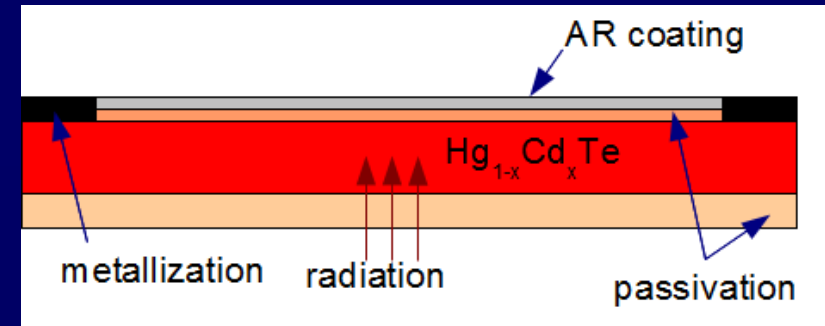
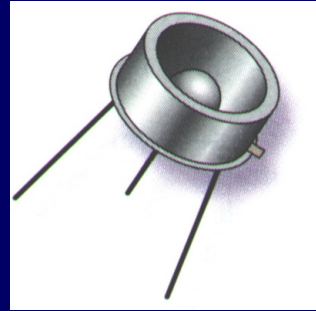
difusion $\tau = t^2 / 2D_a$

drift $\tau = t^2 / V\mu_a$

good: large ambipolar μ_a and D_a



Fast photoconductors



Advantages

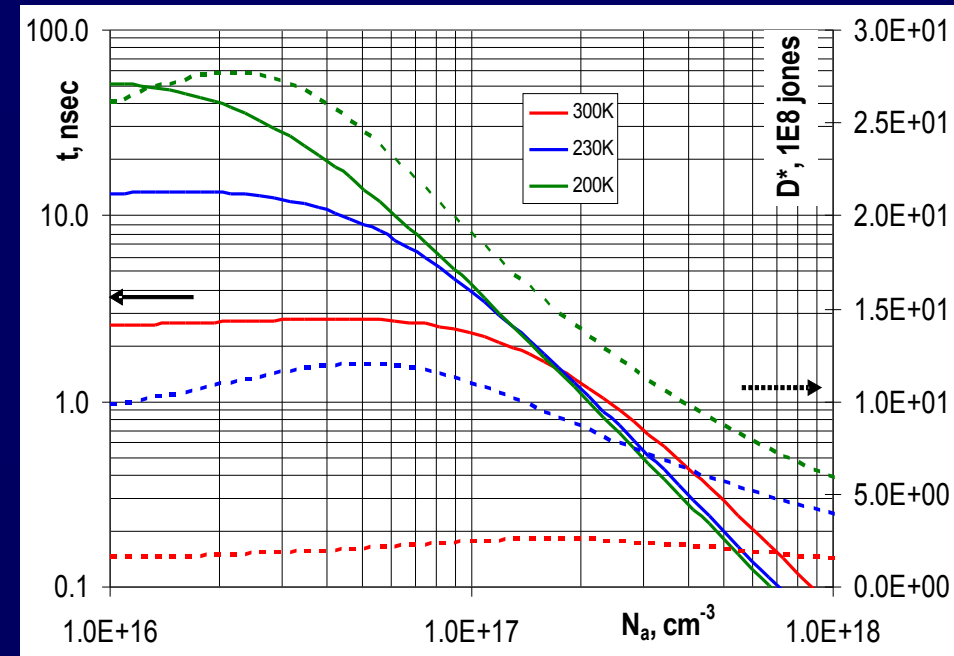
- ▶ simple device
- ▶ low capacitance

Disadvantages

- ▶ low D^*
- ▶ large reverse dark current
- ▶ low resistance

Design Principles

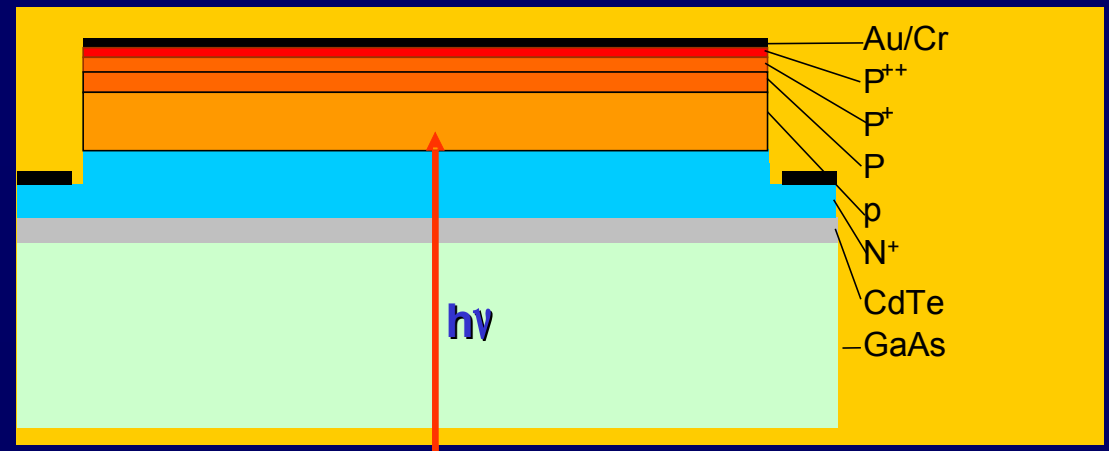
- ▶ heavy p-type doping
- ▶ narrow gap absorber
- ▶ optimized bias
- ▶ preamplifier optimized for low R_d
- ▶ optical immersion for D^*
- ▶ electronics: current readout



Fast photodiodes

Design Principles:

- ▶ N^+ base: low R_s
- ▶ lightly p-doped absorber
- ▶ reduced absorber thickness
- ▶ optimized reverse voltage
- ▶ low parasitic impedances at interfaces
- ▶ optical immersion: reduce physical size for small RC
- ▶ electronics: current readout



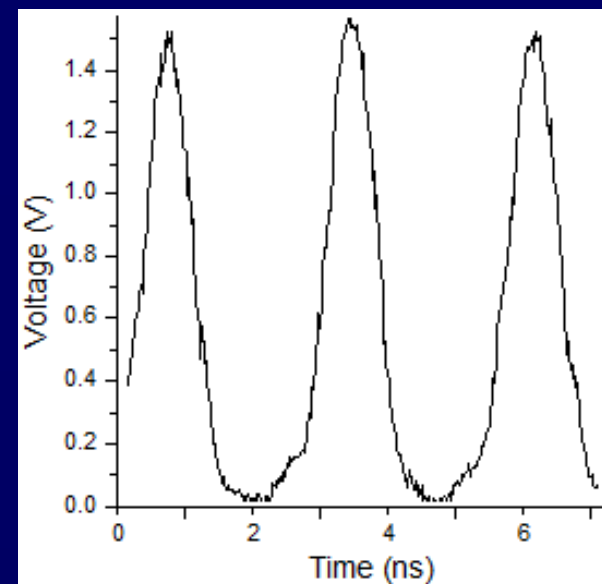
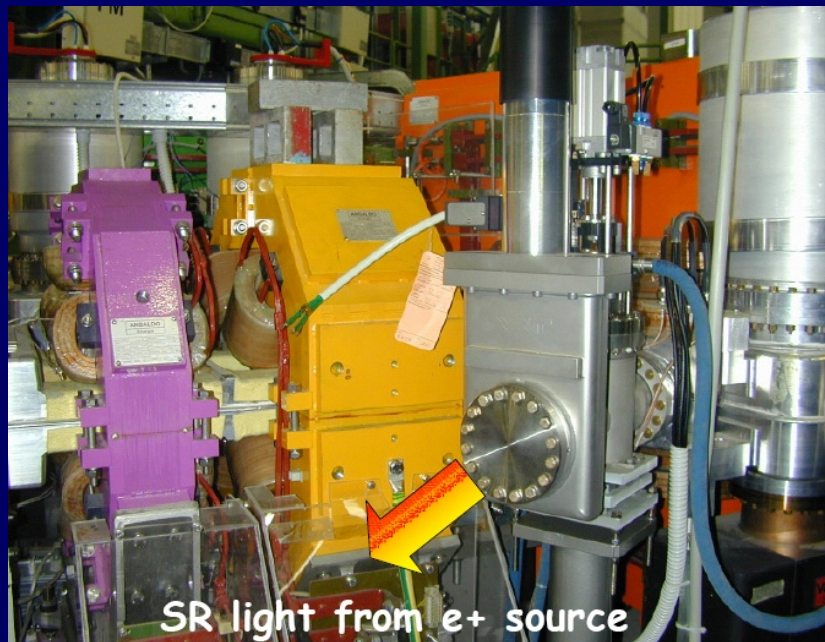
Measurements of time response at INFN and VIGO

Preferred conditions

- ▶ constant voltage bias
- ▶ current readout

Electronics

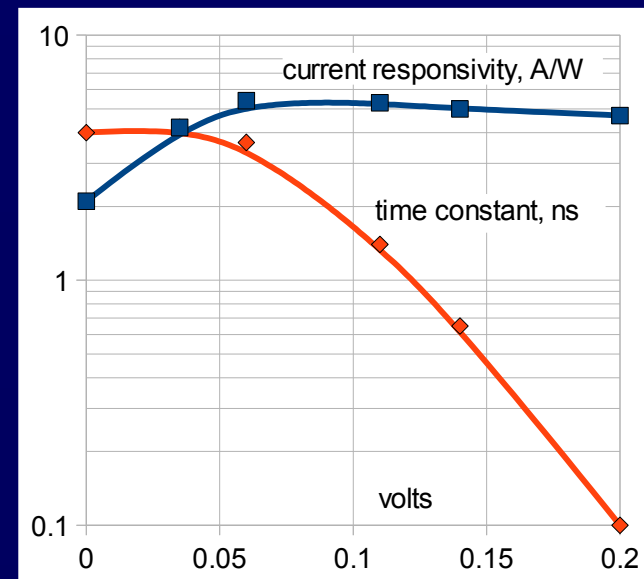
- ▶ DC-coupled TI PA
- ▶ fast oscilloscope



waveforms observed with synchrotron source

Results:

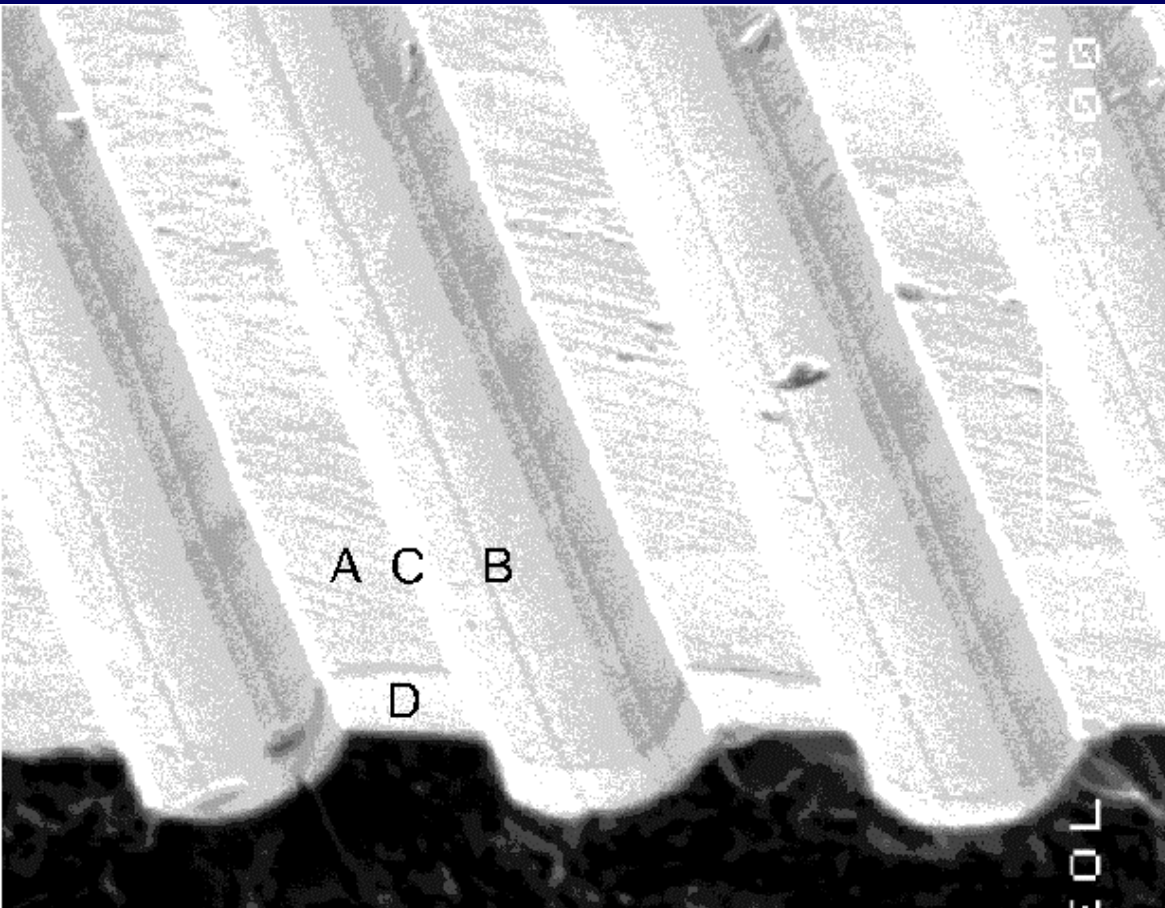
- subnanosecond time constants measured
- in PC, PEM and PV HOT detectors
- with SR, QCL and OPO sources
- agreement with simulations



time constants vs bias in PVI-2TE-11 μm device

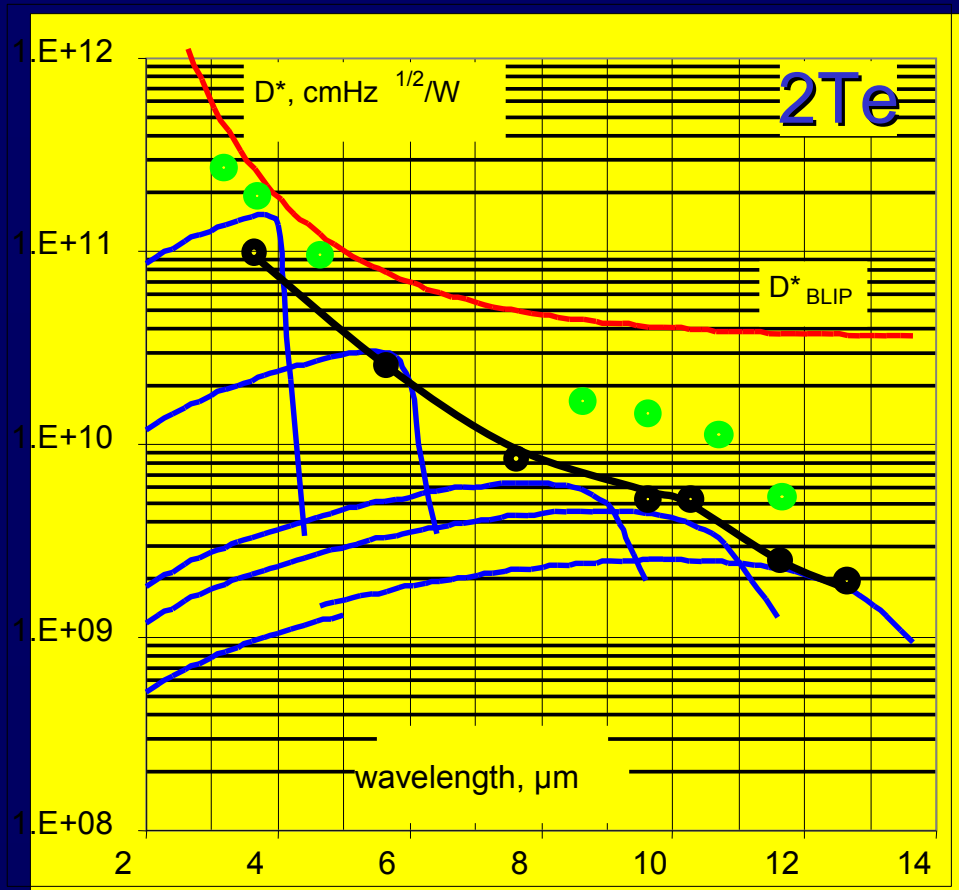
MULTIPLE HETEROJUNCTIONS PV

- First uncooled LWIR PV devices on market (1996-)
- Photonics Spectra Award (1996)
- Micromachined using ion milling and wet etching
- Multiple heterojunction cells with $\sim 10 \mu\text{m}$ period



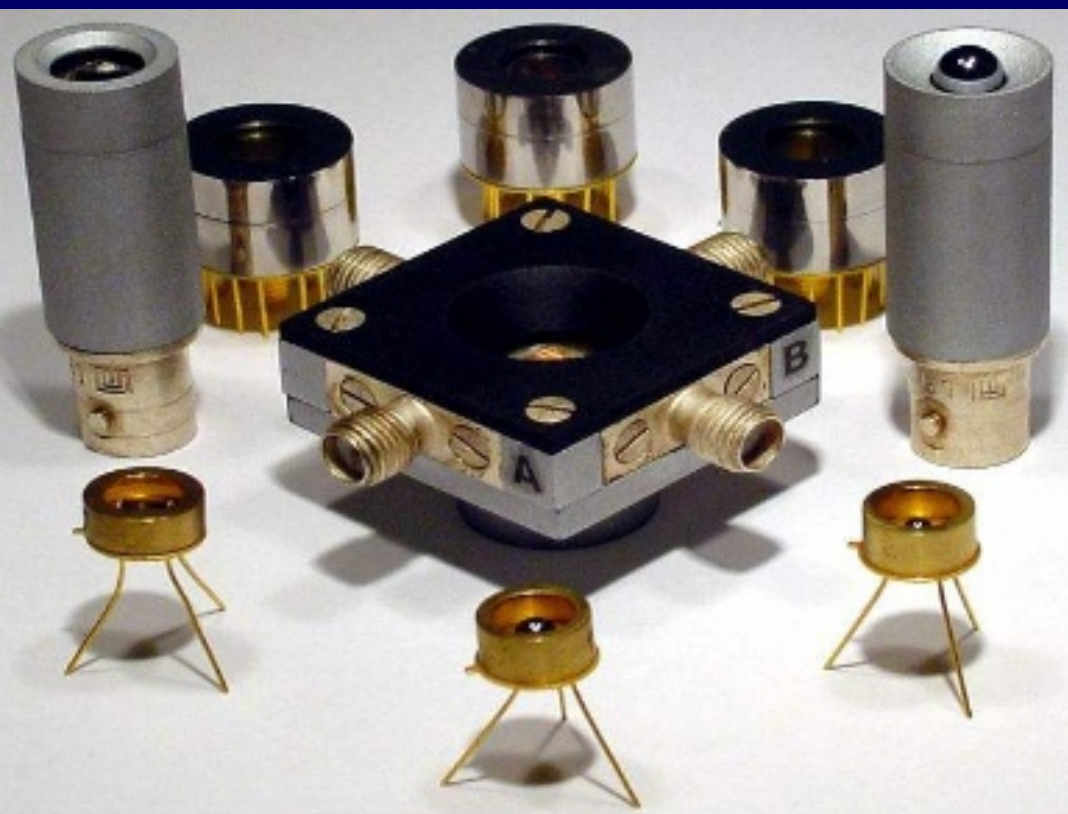
- good responsivity
- large voltage output
- D^* far from limits
- long response time
- dead regions
- polarization sensitive

WHERE WE ARE NOW...



- ❖ near-BLIP detection in 3-5 μm range
- ❖ <1 order of magnitude to BLIP for $\lambda > 7 \mu\text{m}$

PRACTICAL „HOT” DEVICES...



Standard devices

$$2 < \lambda < 16 \mu\text{m}$$

- o PC, PCI
- o PC-2TE, PCI-2TE
- o PEM, PEMI
- o PV, PVI
- o PV-2TE, PVI-2TE 3 and TE)
- o PVM (I, 2TE)
- o 3TE and 4TE versions

Custom devices:

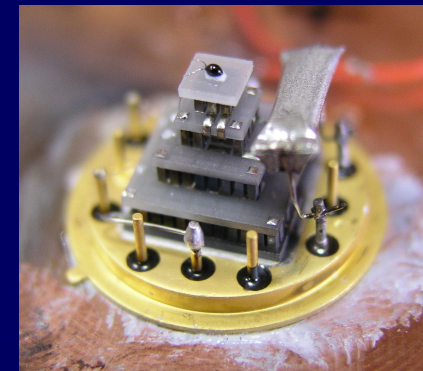
- o LN cooling
- o shaped spectral response and multicolor
- o linear arrays up to 120 el.
- o small 2D arrays e.g. quads
- o sizes: from few μm to a few mm
- o no large 1- and 2D arrays!

Improving Peltier cooling

Cooling depends on thermal losses and can be improved with better insulation

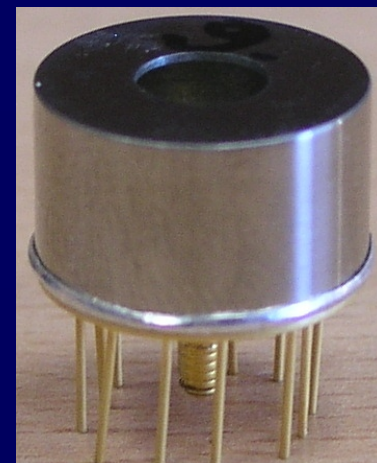
Recent improvements

- ❖ anti-convection shields for gas filled packages
- ❖ vacuum thermal insulation
- ❖ new getters for xenon (Ba) and vacuum (Zr)
- ❖ indium sealing of detector package
- ❖ reduced power consumption
- ❖ miniaturized TO-8 packages for 3TE and 4TE

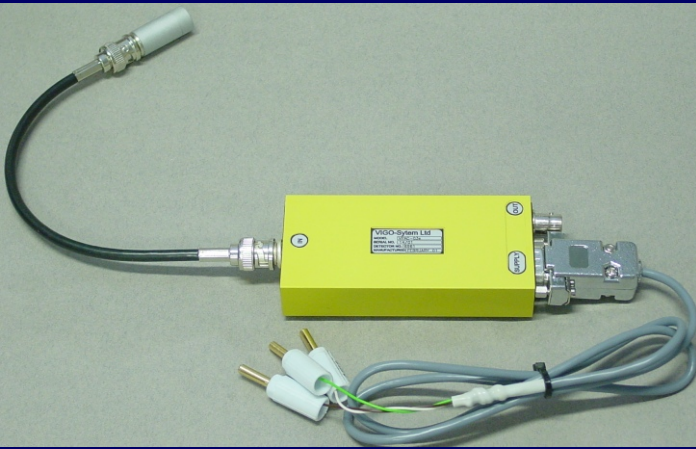


Achievable temperatures ($T_{\text{sink}} = 300 \text{ K}$)

- 2 TE 220 K Xe mixture
- 3 TE 190 K vacuum
- 4 TE 180 K vacuum



DETECTION MODULES- design and fabrication



Low noise PA (+ detector bias):
voltage and current, DC to GHz

Integrated Packages and OEM Modules

- ▶ **Detector**
- ▶ **TE cooler**
- ▶ **electronics: PA, bias, TE controller, A/D**
- ▶ **optics**

Advantages

- ▶ **Rugged,**
- ▶ **Miniaturized**
- ▶ **Less vulnerable to EMI**
- ▶ **Fast (GHz)- reduction of parasitic impedances**



IR SYSTEMS at Vigo

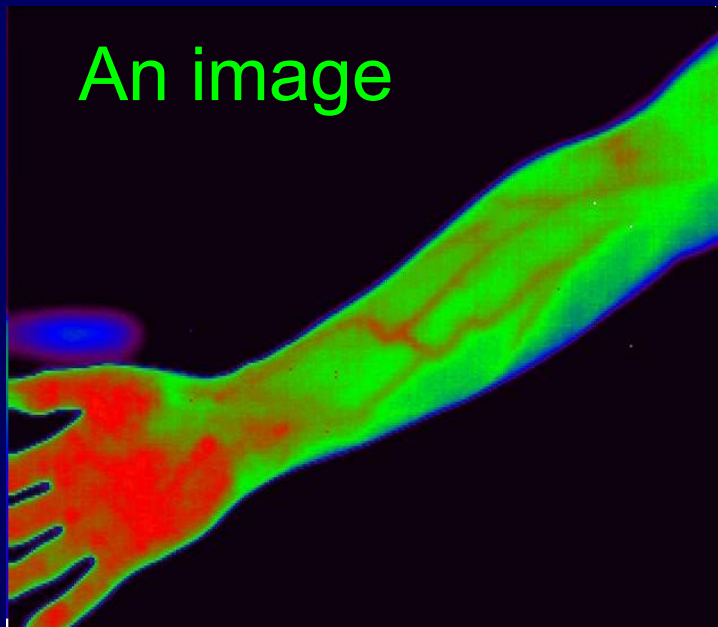
- Solutions for measurements of temperature, pressure, flow etc.
- Software for advanced data processing



Fast pyrometer



An image



High resolution
384x288 and 480x640
μ-bolometer cameras

APPLICATIONS of HOT DEVICES

NDT

spectroscopy

gas analyzers

plasma physics

smart munition

laser metrology

laser technology

laser microfusion

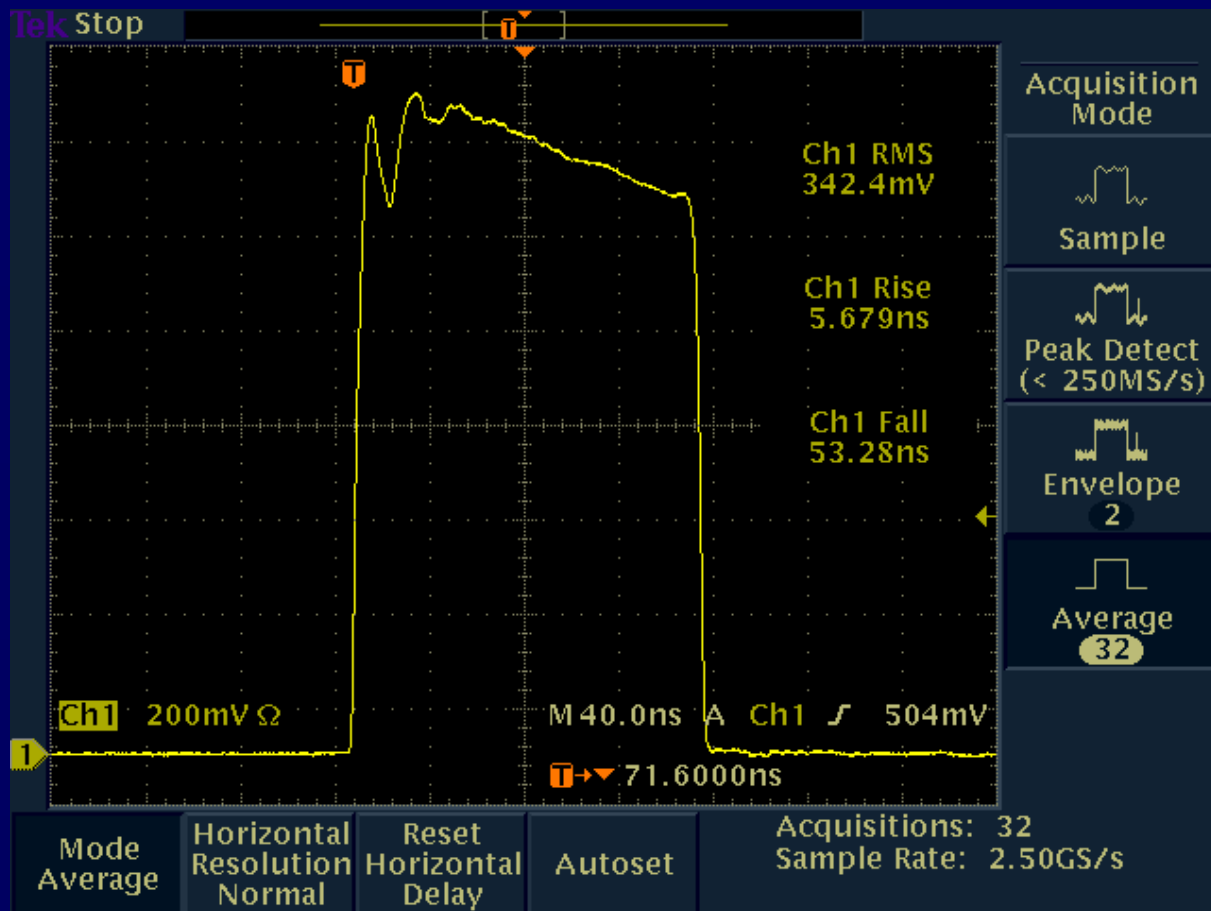
ultrafast pyrometry

optical communications

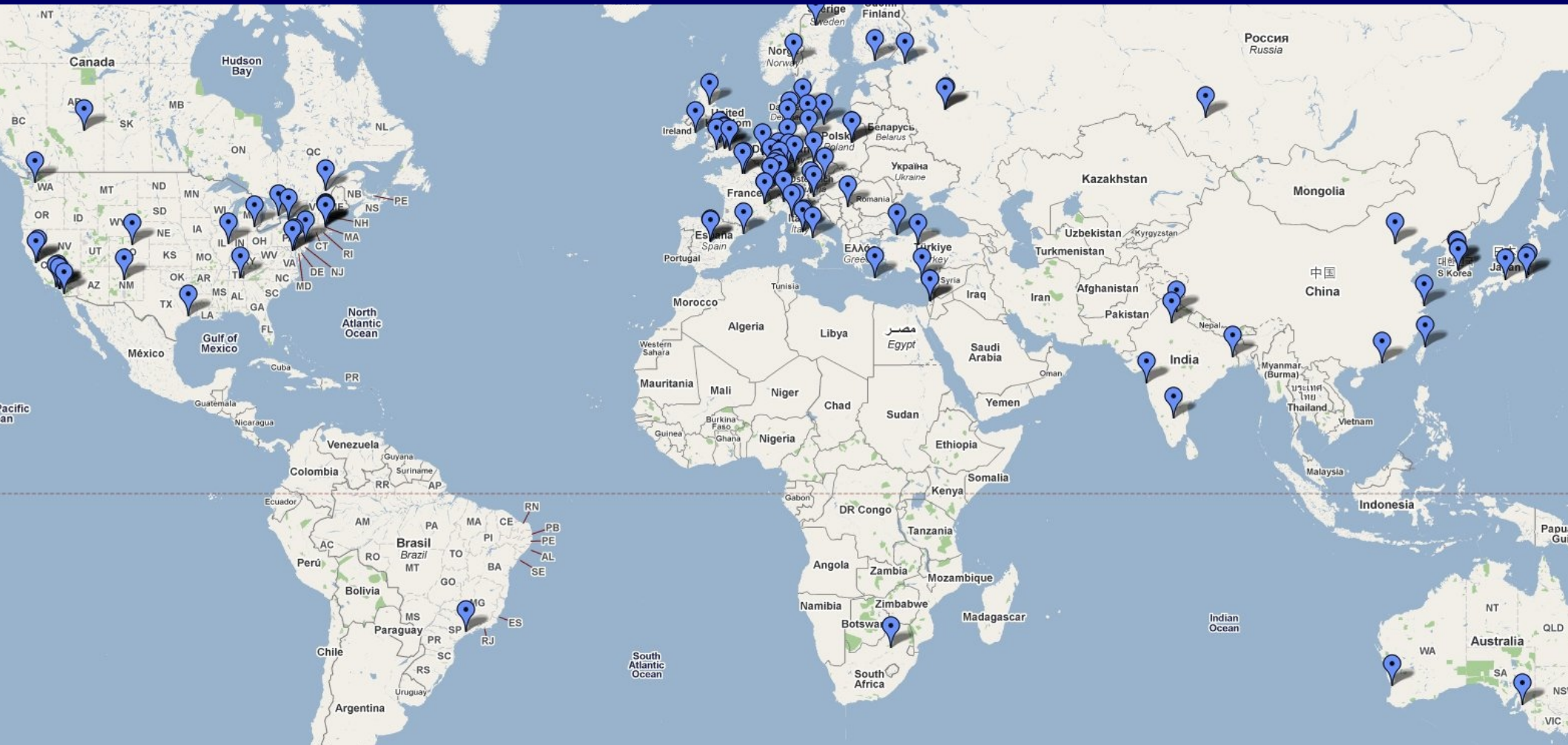
laser rangefinders/alerters

CO₂ and quantum cascade laser systems

lidars.... and many others



Users of HOT photodetectors manufactured at VIGO Systems S.A.



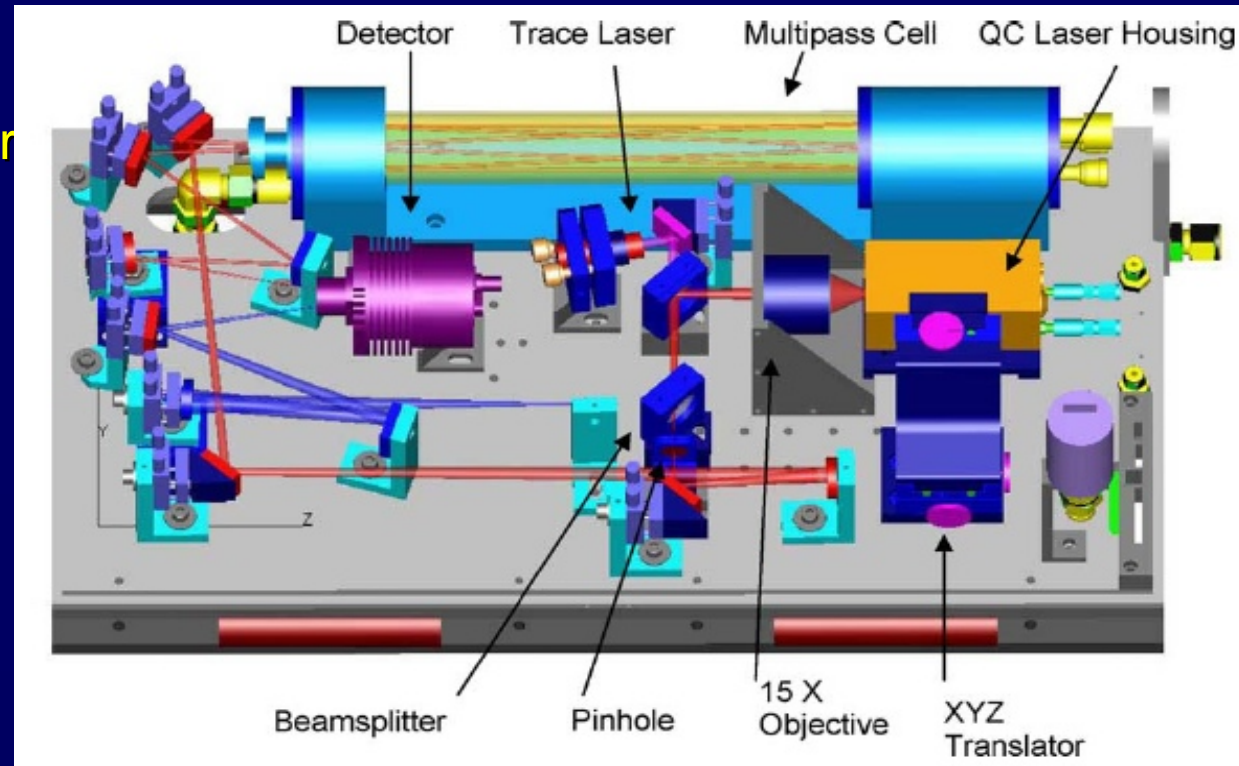
QC LASER-BASED SENSORS

-high end ppb/ppt chemical sensing

Aerodyne Research

„A precision of $0.3 \text{ ppb Hz}^{-1/2}$ is obtained using a Vigo thermoelectrically cooled detector which allows continuous unattended operation over extended time periods with a totally cryogen-free instrument”

D. D. Nelson et al, „Sub part-per-billion detection of nitric oxide in air using a thermoelectrically cooled mid-infrared quantum cascade laser spectrometer”, Appl. Phys. (B), 2002



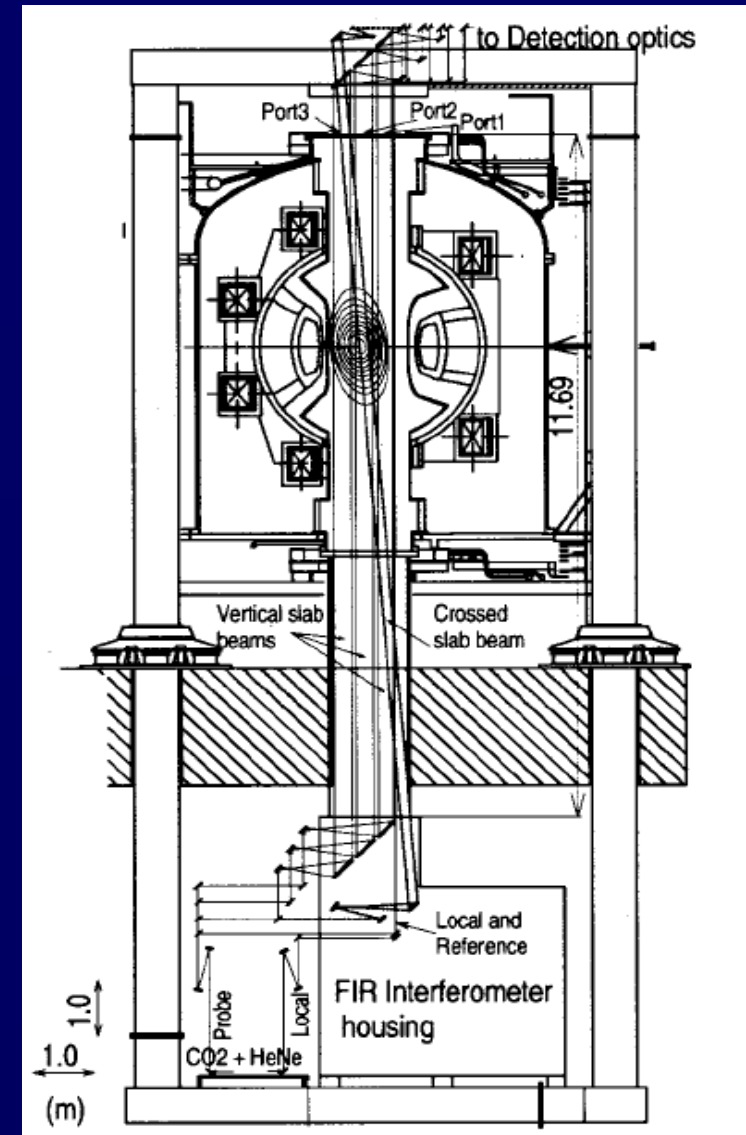
- non-invasive medical diagnostics: pre-cancer and other illness detection
- narcotics and explosives detection
- air and water quality monitoring
- industrial and science applications

Laser Technology

- monitoring of laser welding, cutting, scribing, drilling and marking
- monitoring of laser surgery
- NDT systems

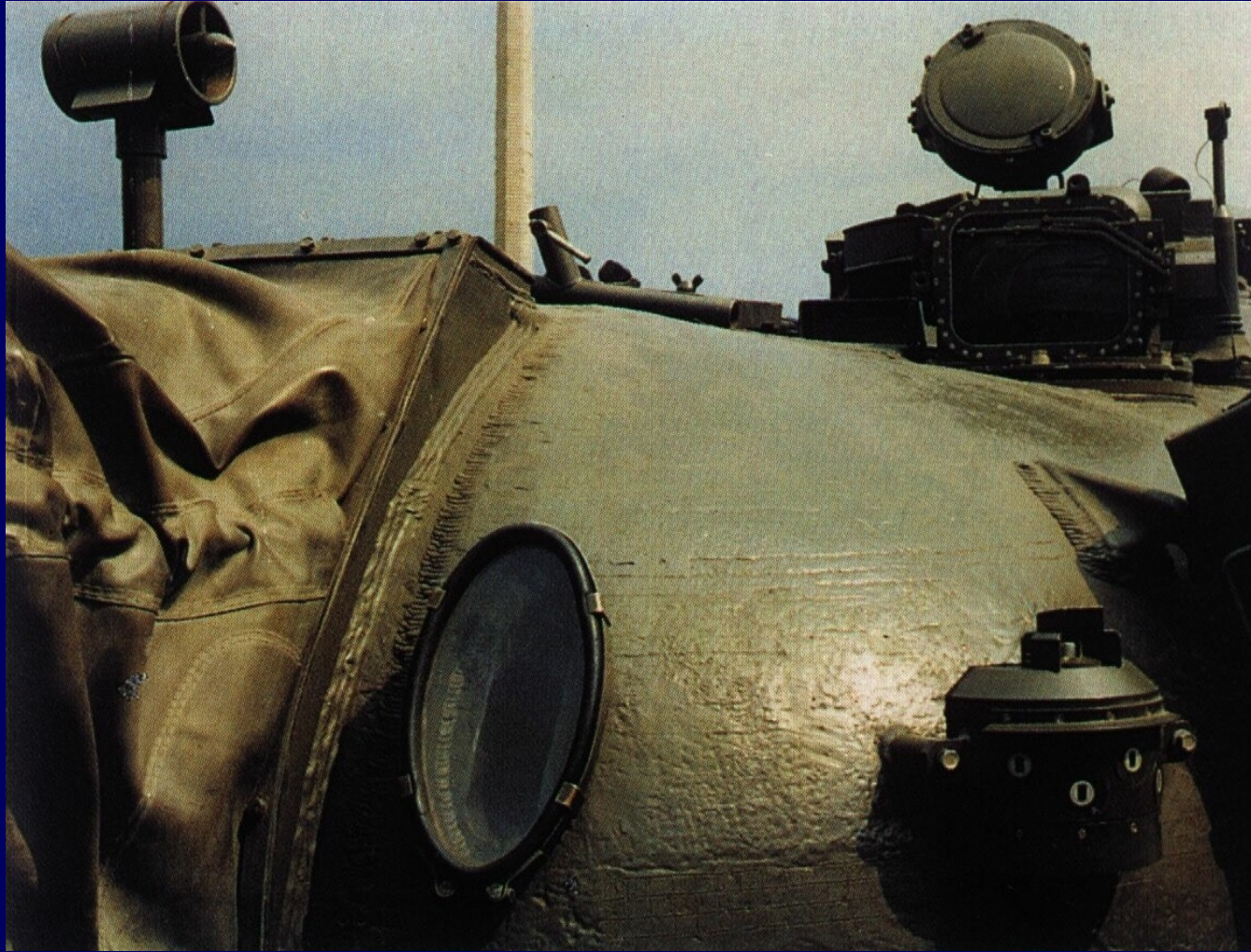
Plasma Research

- various systems in EU, US, Japan



K. Tanaka *et al*, „CO₂ laser imaging interferometer on LHD” Rev. Sci. Instr. 72 1081 (2001)

LASER THREAT WARNING SYSTEMS

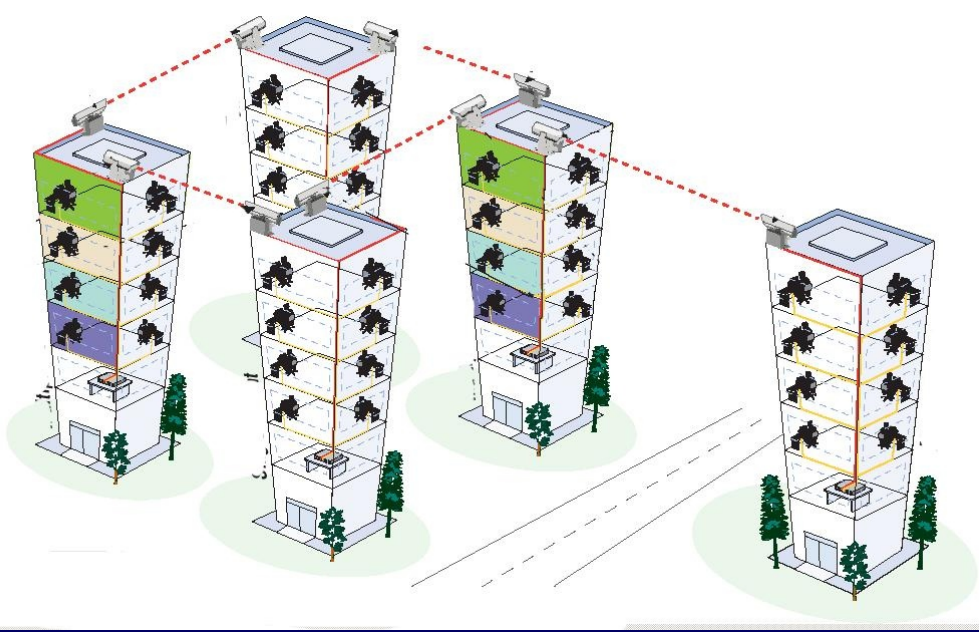


POLISH "OBRA" TANK LASER WARNING SYSTEM

- uncooled VIGO detectors
- spectral range 0.5-11 μm (all laser rangefinders)
- detection range 9 km

FREE SPACE OPTICAL COMMUNICATION

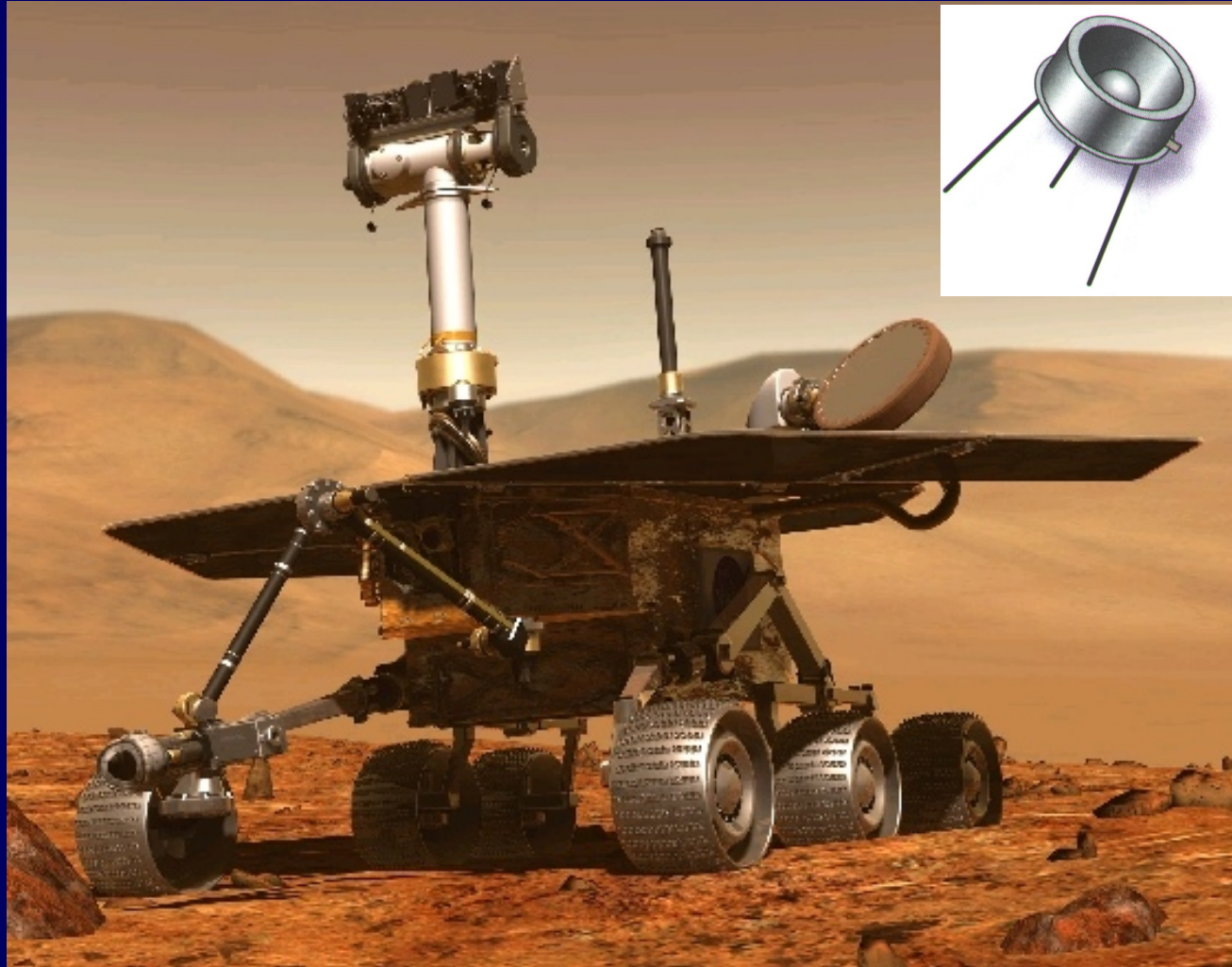
-second generation



Features:

- large transfer rates (GB/s)
- all-weather operation with $\lambda=10 \mu\text{m}$ devices
- licence-free solution for last mile problem (internet, cellular)

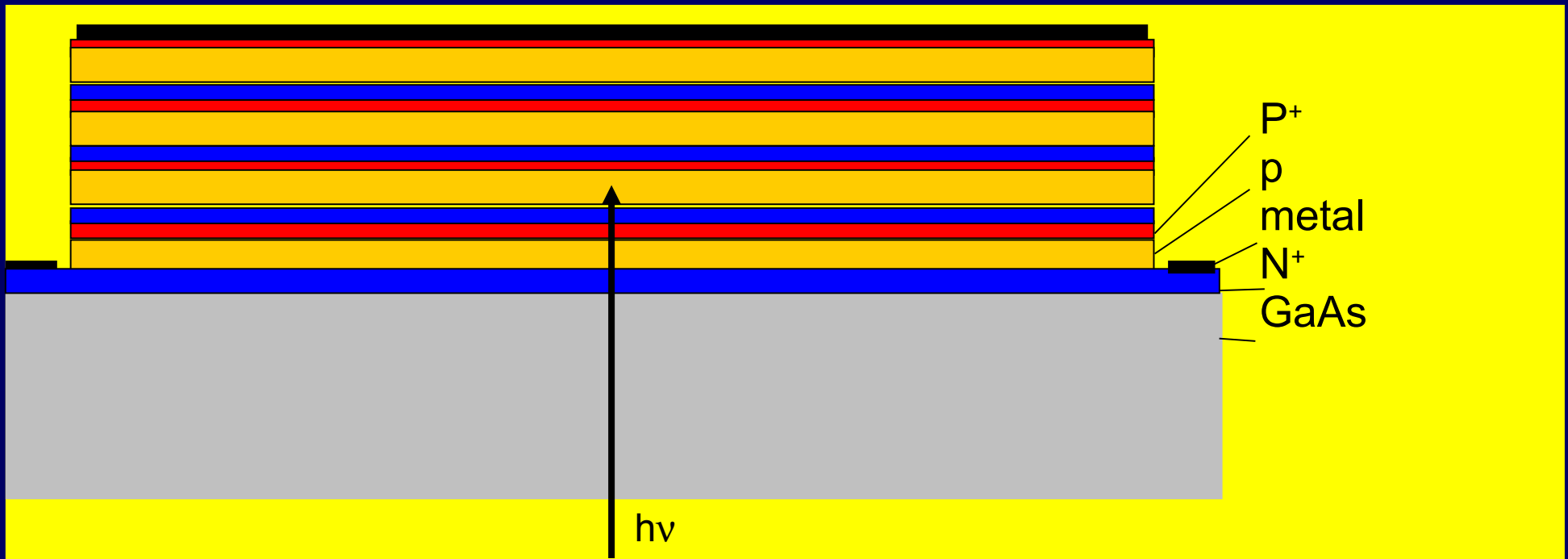
SPACE APPLICATIONS of VIGO DEVICES



2011 NASA Mars Science Laboratory Mission

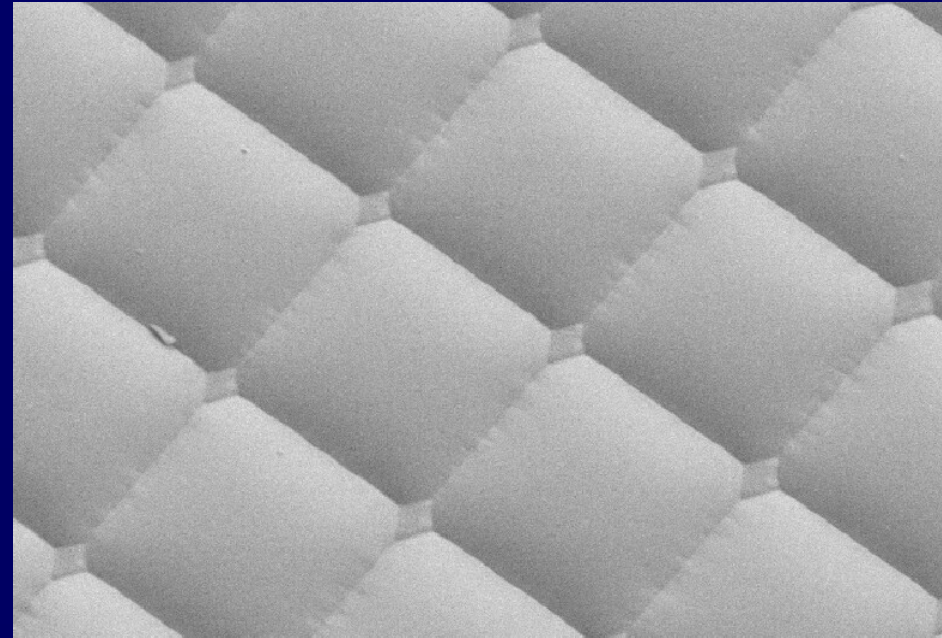
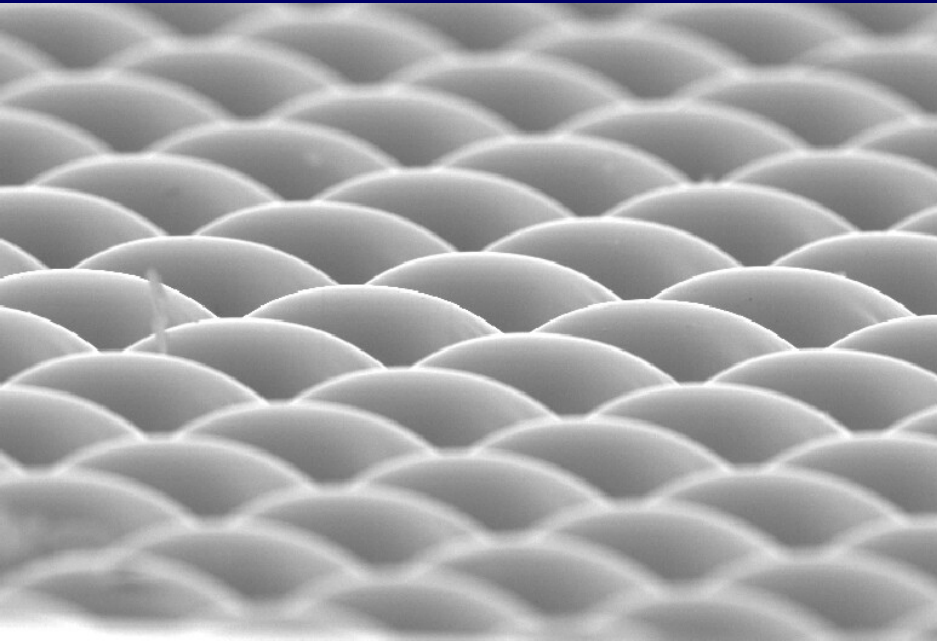
- ▶ uncooled PVI-4 and PVI-8.2 for extreme requirements
- ▶ remote chemical analysis in search of life traces

STACKED MULTIPLE HETEROJUNCTIONS



- ▶ multiple N⁺pP⁺ cells
- ▶ $d_{\text{abs}} < L_d$, $d_{\text{tot}} \approx 1/\alpha$
- ▶ high QE and efficient collection
- ▶ very short response time
- ▶ problems: interdiffusion, N⁺P⁺

Arrays of μ -lenses



- ▶ $\approx 50 \mu\text{m}$ pitch CdZnTe, GaAs or Si
- ▶ combination of ion milling and wet etching
- ▶ photolithography assisted

not commercialized yet: run-to-run reproducibility problems

„HOT” PHOTODETECTORS REVIEWS

- ▶ J. Piotrowski, W. Galus and M. Grudzien
"Near Room-Temperature IR Photo-detectors"
Infrared Phys. 31, 1,1-48. (1991)
- ▶ J. Piotrowski, "Hg_{1-x}Cd_xTe Infrared Photodetectors" in: *Infrared Photodetectors*, 391-494, SPIE, Bellingham (1995)-ed. A. Rogalski
- ▶ J. Piotrowski and A. Rogalski,
„High-Operating Temperature Infrared Photodetectors”,
SPIE, Bellingham (2007)
- ▶ J. Piotrowski and A. Piotrowski
„Uncooled photodetectors”
Willey (2010- to be published)